

REISSUE APPLICATION-SUBJECT TO EXPEDITED PROCESSING

3-23-04 P2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Inventor:

Takeshi YUKITAKE, et al.

Examiner: R. Lee

Serial No.:

09/559,627

Art Unit: 2613

Reissue Application of

U.S. Patent No. 5,745,182

Filed:

April 27, 2000

For:

METHOD FOR DETERMINING MOTION COMPENSATION

AMENDMENT

Assistant Commissioner of Patents Washington, DC 20231

Sir:

Attention
Special Application Subject to Expedited
Processing

In response to the Office Action dated January 15, 2004, please amend this application as follows:

RECEIVED

MAR 1 9 2004

Technology Center 2600